E UNITED STATES PATENT AND TRADEMARK OFFICE In Re Application of: LIOU et al. Examiner: NADAV Serial No.: 09/467,675 Art Unit: 2811 Filed: Dec. 21, 1999 Docket No.: 252103-4540 Structure For ESD Protection With Single For: Crystal Silicon Sided Junction I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on May 30, 2001.

AMENDMENT AND RESPONSE TO OFFICE ACTION

Assistant Commissioner of Patents and Trademarks Washington, DC 20231

Sir:

The Office Action mailed April 12, 2001 (Paper No. 4), has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

In The Claims

Please cancel claim 17 without prejudice and disclaimer.

Please amend claims 1, 9, and 21 by substituting the following clean text claims for the pending claims of the same number.